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UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Tadashi WATANABE et al.**

Group Art Unit: **2818**

Application No.: **10/823,729**

Examiner: **David Vu**

Filed: **April 14, 2004**

Confirmation No.: **5344**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042341**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 6, 2005

Sir:

This Amendment is in response to the Office Action of September 7, 2005, having a response due date set for December 7, 2005. The following amendments and remarks are respectfully submitted.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 13 of this paper.